

**PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Serial No.: 10/797,876  
Applicant: Dip et al.  
Art Unit: 2811  
Examiner: Colleen Matthews  
Title: **SILICON GERMANIUM SURFACE LAYER FOR HIGH-K  
DIELECTRIC INTEGRATION**  
Attorney Docket: TPS-007  
Confirmation No.: 5070

March 2, 2009

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

**AMENDMENT - AFTER NON-FINAL REJECTION**

This paper is responsive to the Office Action mailed December 1, 2008.

The present response includes the following:

Amendments to the Specification:	None
Amendments to the Claims:	Pages 2–6
Amendments to the Abstract:	None
Amendments to the Drawings:	None
Remarks:	Pages 7–13
Attachments:	None